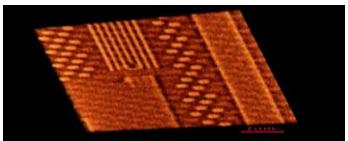


纳米三维成像光束线站 (BL18B)

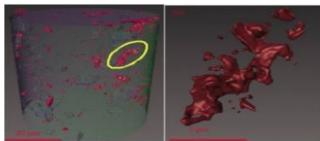
科学目标: 物质内部纳米尺度结构的X射线全场纳米成像研究

线站主要参数	
光源	弯铁
成像模式	TXM, Nano-CT
能量范围	5-14keV
能量分辨率($\Delta E/E$)	5×10^{-4} @8keV
空间分辨率	20 nm @8keV (TXM)
样品处光通量	$1.3 \times 10^{10} \text{ phs/s}$ @8keV

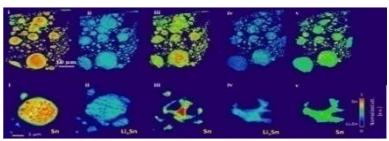
研究领域:



集成电路



页岩气



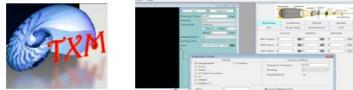
能源材料



生命科学

自主研制具有完全知识产权的纳米CT系统

□ 纳米CT控制及数据采集软件



□ 单毛细管椭球聚焦镜

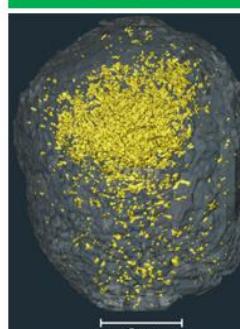


实验方法:

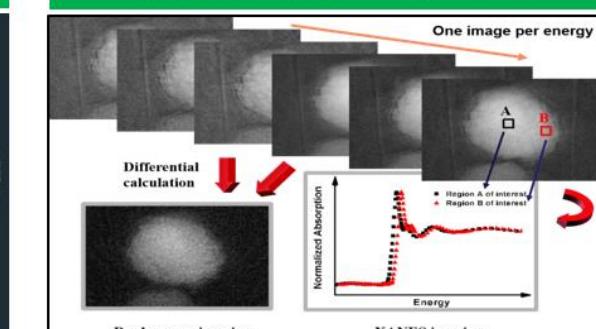
20nm TXM成像



纳米CT

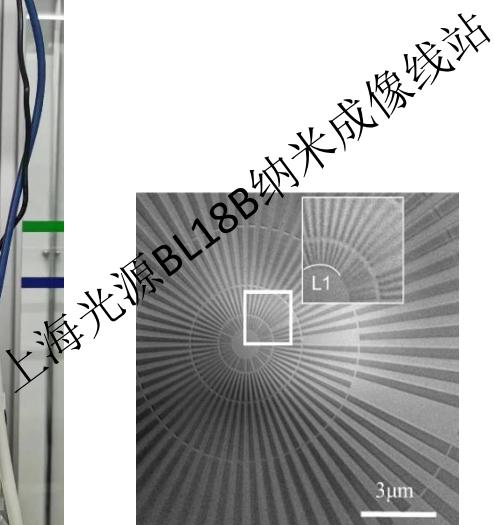


元素分辨成像/谱学成像



双模式TXM成像

□ 高分辨模式



空间分辨率: 20-40nm
视场: 10-20μm
单张曝光时间: 1-5s @8keV

□ 中等分辨模式

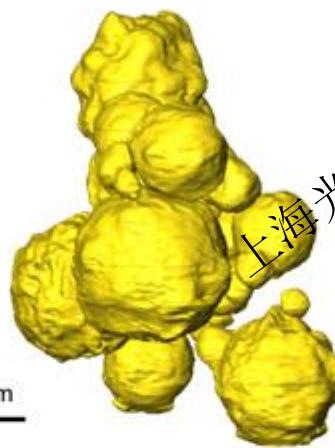
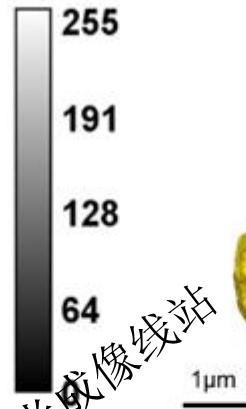
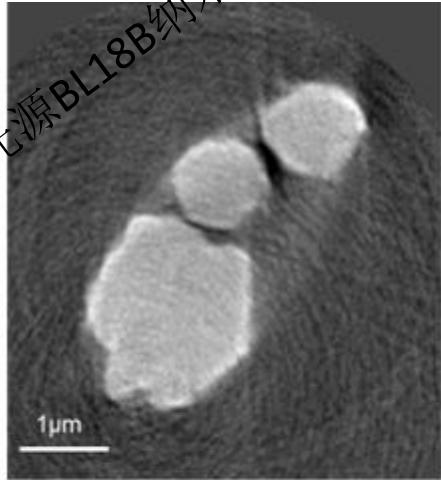


空间分辨率: 50-100nm
视场: 10-30μm
单张曝光时间: 0.3-3s @8keV

高Z/低Z 材料纳米CT

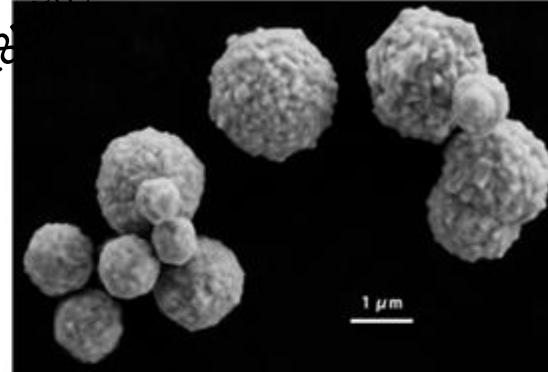
上海光源BL18B纳米成像线站

Au



上海光源BL18B
纳米成像线站

上海光源BL18B
纳米成像线站



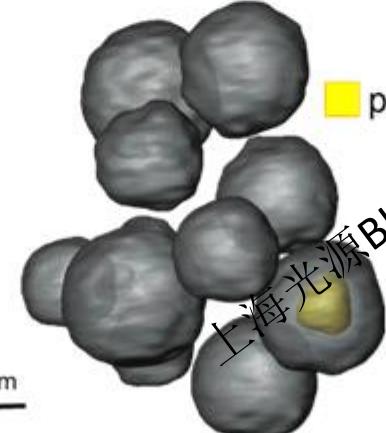
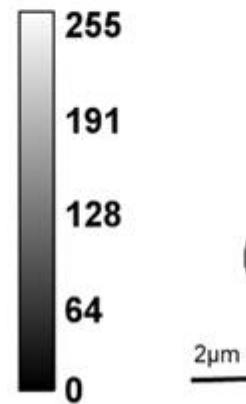
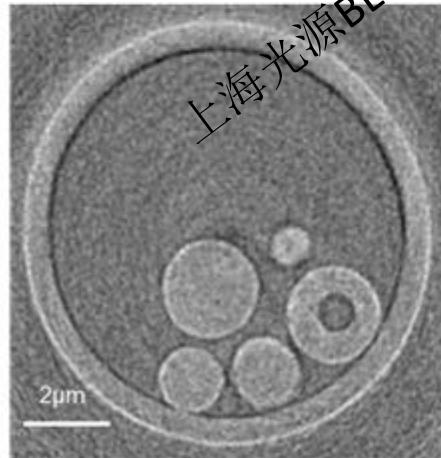
金球: 19.37 g/cm^3

高分辨模式

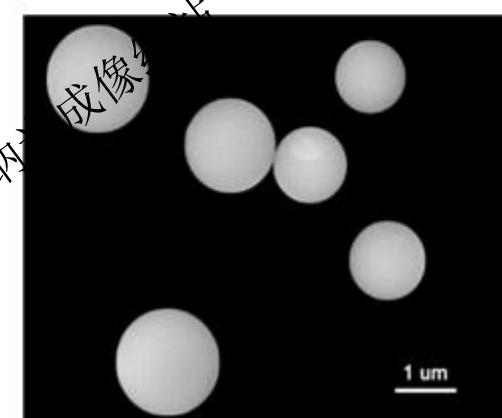
单次曝光时间5s @8keV

上海光源BL18B纳米成像线站

SiO_2



上海光源BL18B
纳米成像线站



SiO_2 球: 2.3 g/cm^3

中等分辨模式

单次曝光时间5s @5.2keV

纳米CT重构切片

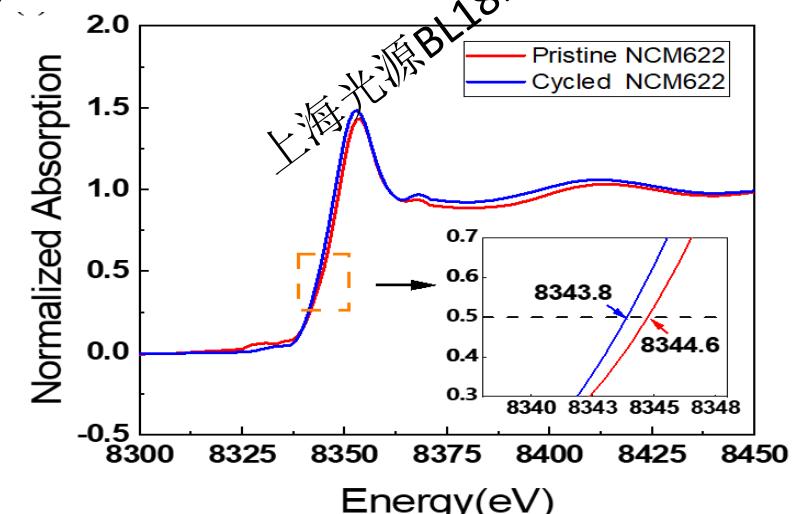
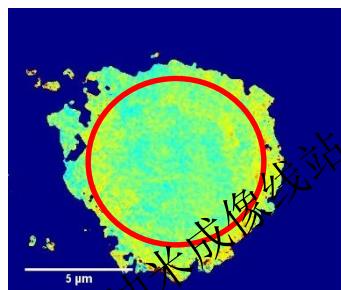
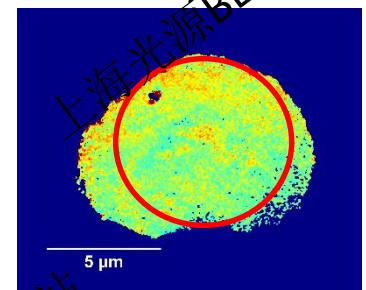
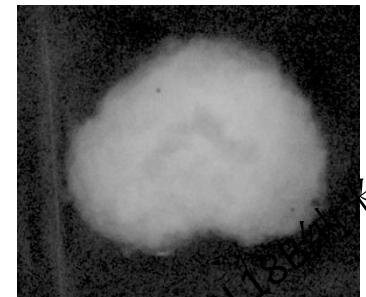
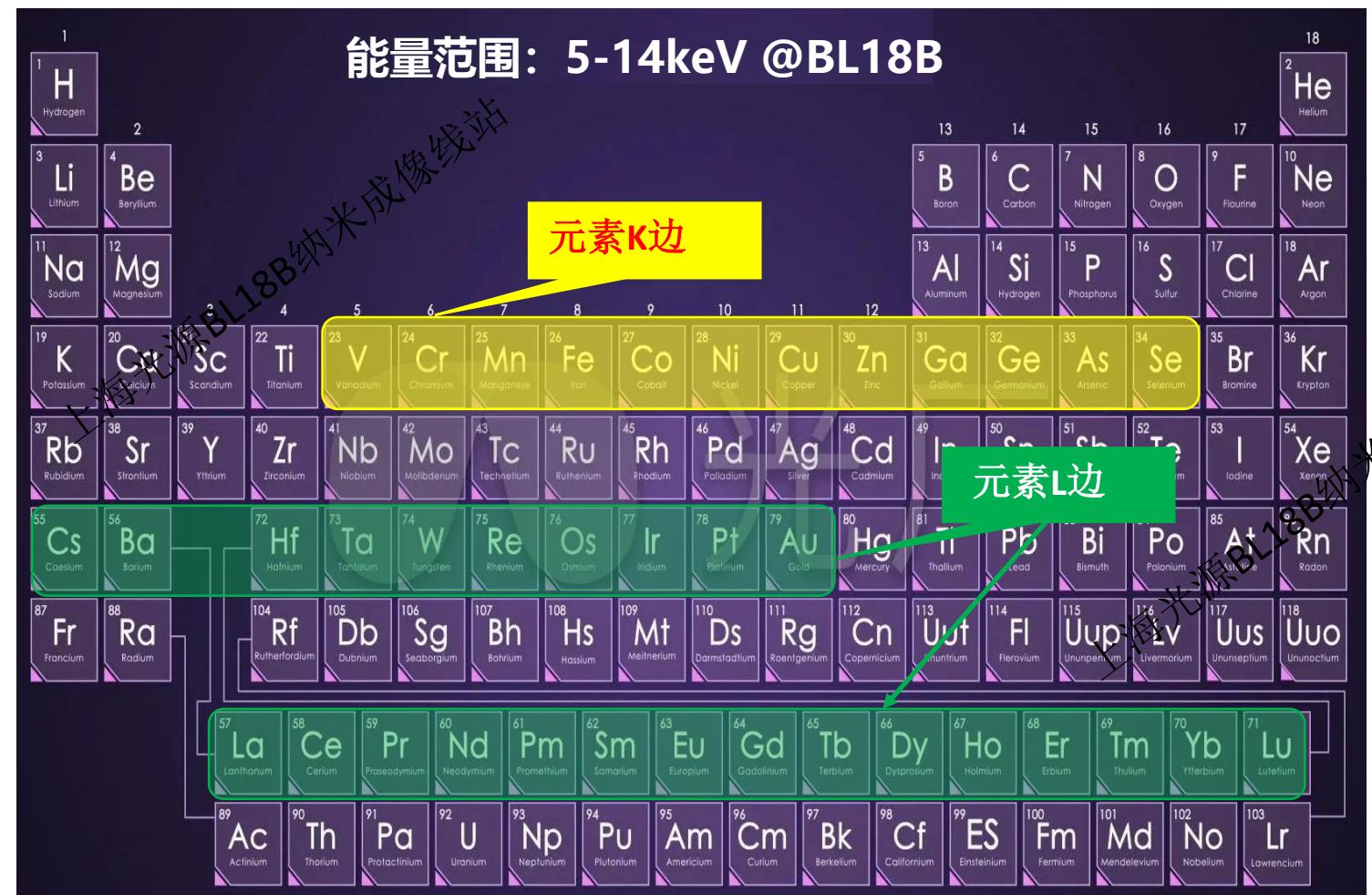
重构三维图

样品SEM照片

纳米元素分辨/谱学成像

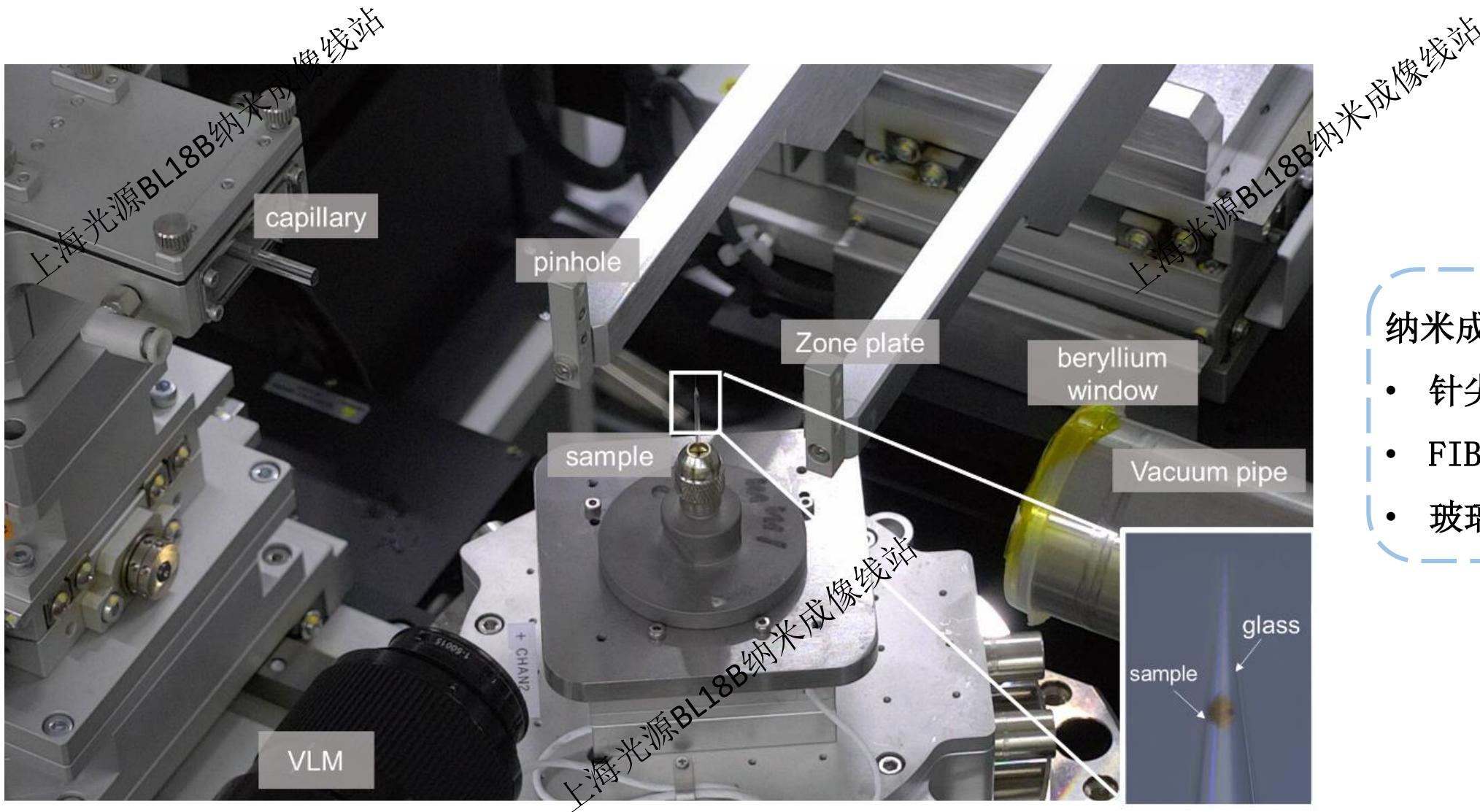
原始颗粒

完全放电循环后的颗粒



锂电正极材料 $\text{LiNi}_{0.6}\text{Co}_{0.2}\text{Mn}_{0.2}\text{O}_2$ (NCM622)

上海光源BL18B线站-纳米CT样品制作及安装



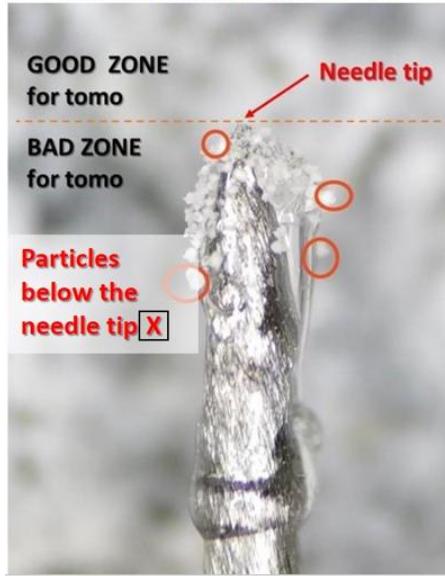
纳米成像样品制备方法:

- 针尖粘贴式
- FIB切割微柱
- 玻璃管封装

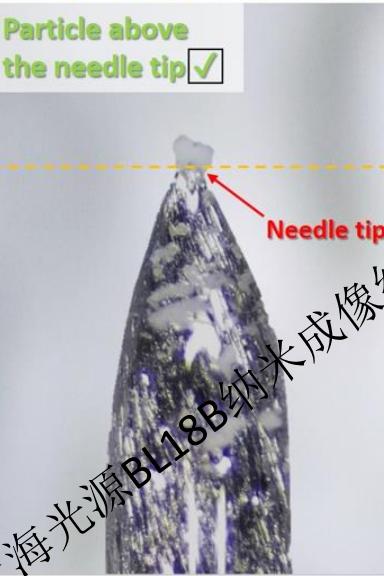
纳米CT样品安装

针尖粘贴式

Bad sample preparation



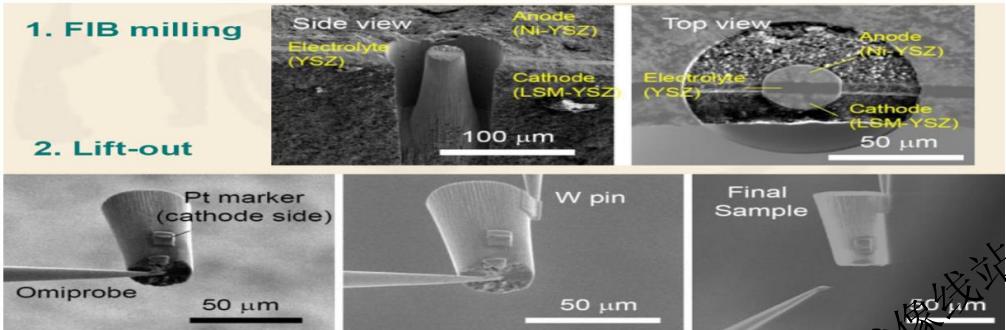
Good sample preparation



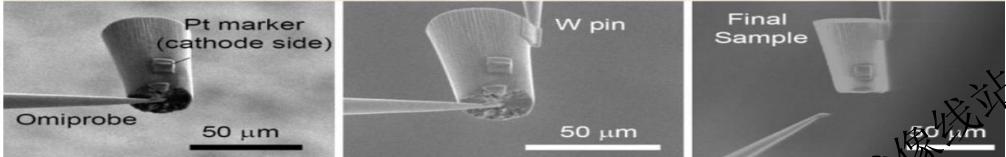
FIB切割微柱

1. FIB milling

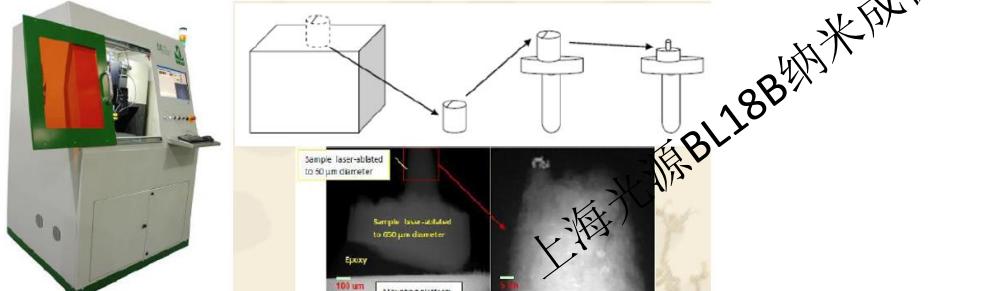
2. Lift-out



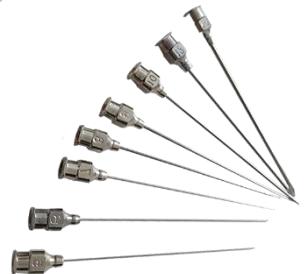
FIB聚焦离子束刻蚀:



激光切割:



玻璃管封装



工业点胶器
样品递送

+

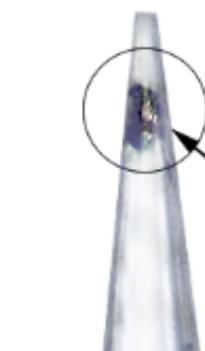


血检取样管夹持器
玻璃管夹持

+



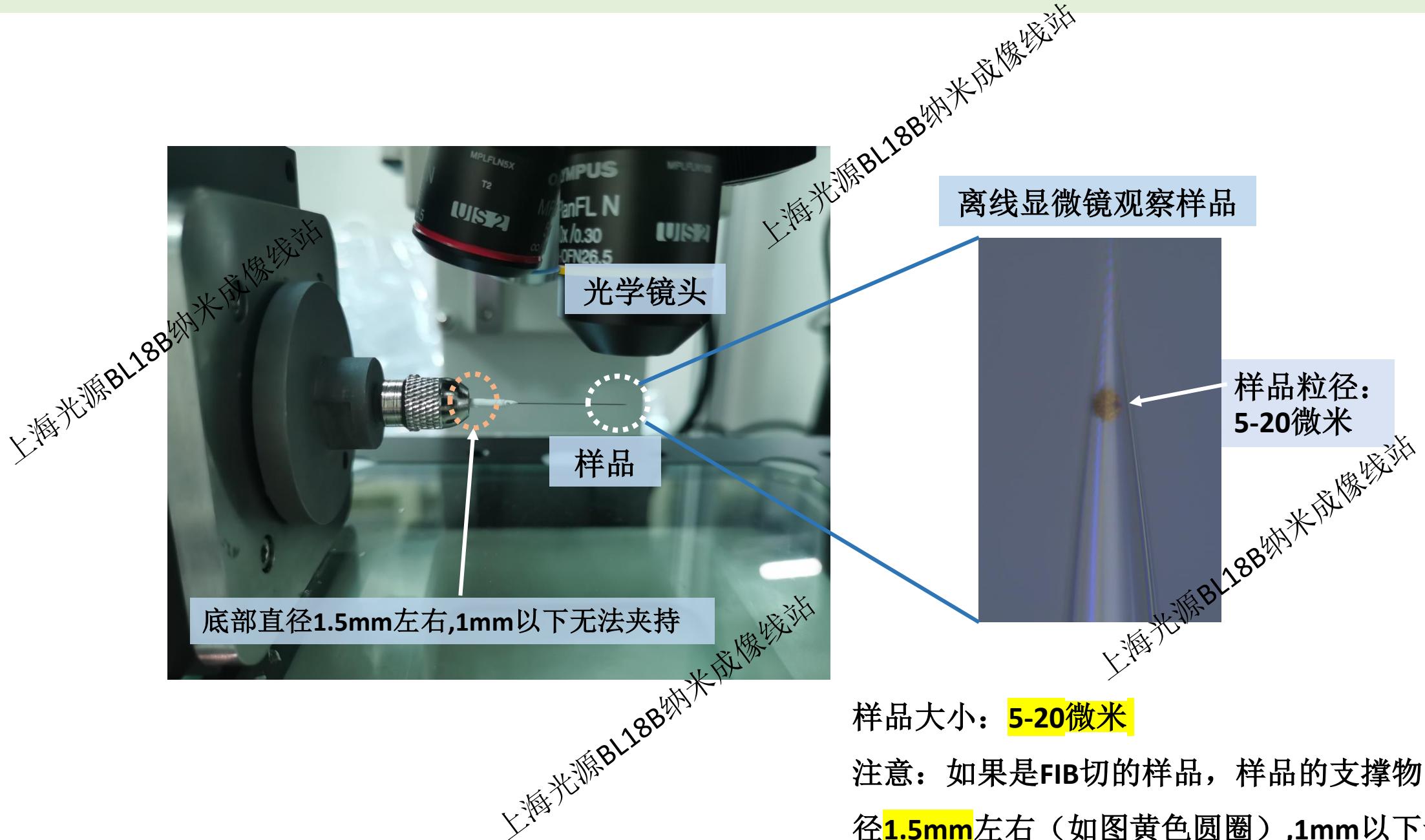
微米尖端玻璃管
样品定位及吸附



样品固定区

- 简洁高效
- 经济可行
- 普适性强
- 拓展性高

离线样品观察





上海光源BL18B纳米成像线站

上海光源BL18B纳米成像线站

上海光源BL18B纳米成像线站

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E-mail: zhangl@sari.ac.cn